IFW #



PATENT Customer No. 22,852 Attorney Docket No. 7553.0019-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Chishio KOSHIMIZU et al.) Group Art Unit: 1763
Application No.: 10/675,966) Examiner: P. Hassanzadeh
Filed: October 2, 2003))
For: PLASMA PROCESSING APPARATUS AND PLASMA PROCESSING METHOD) Confirmation No. 6290)
Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	
Sir:	

PETITION FOR EXTENSION OF TIME - THREE MONTHS

Applicants hereby petition for a three month extension of time to reply to the Office Action of July 2, 2004. The fee payment of \$1,020.00 is enclosed.

Please grant any extensions of time required to enter this Amendment and charge any additional required fees to our Deposit Account No. 06-0916.

By:

12/22/2004 SMINASS1 00000036 10675966

Respectfully submitted,

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1020.00 OP

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

Dated: December 21, 2004

Michael W. Kim Reg. No. 51,880